

Docket No.: 1794-0182PUS1
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Hiromichi INAISHI et al.

Application No.: 10/575,758

Confirmation No.: 5126

Filed: March 5, 2007

Art Unit: 2182

For: PRINTED CIRCUIT BOARD DESIGN
INSTRUCTION SUPPORT METHOD AND
DEVICE

Examiner: S. C. Sun

STATEMENT OF THE SUBSTANCE OF THE INTERVIEW

MS AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Madam:

In the Examiner's Interview Summary dated June 4, 2010, the Examiner did not waive the requirement for a statement of the substance of the interview under 37 C.F.R. § 1.133. In view of this, the following comments are provided for the Examiner's consideration.

The Examiner has set forth the substance of the interview in the Interview Summary dated June 4, 2010. Applicants submit that the Examiner's comments are a complete description of the substance of the interview.

CONCLUSION

In the event there are any matters remaining in this application, the Examiner is invited to contact Paul C. Lewis, Registration No. 43,368 at (703) 205-8000 in the Washington, D.C. area.

Dated: **June 4, 2010**

Respectfully submitted,

By 

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